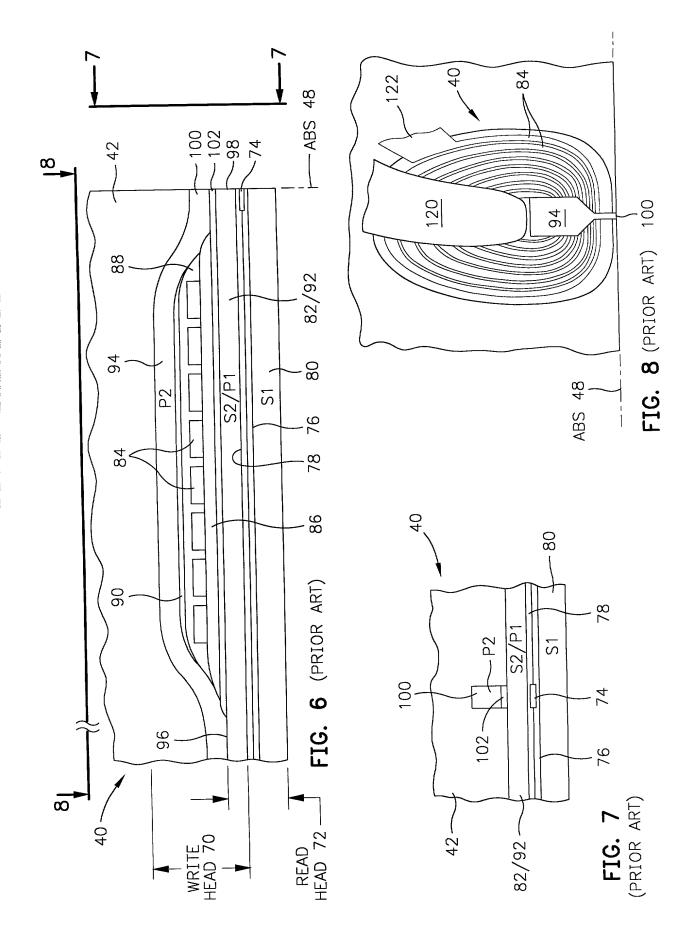
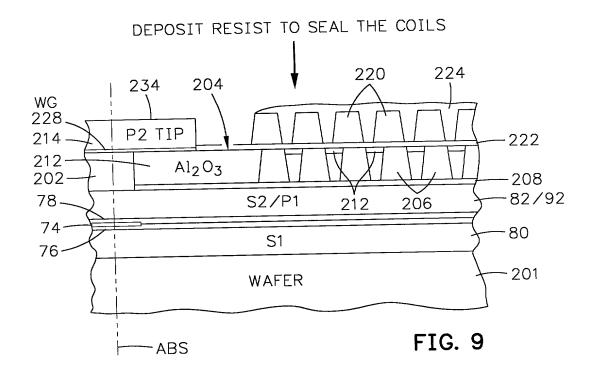
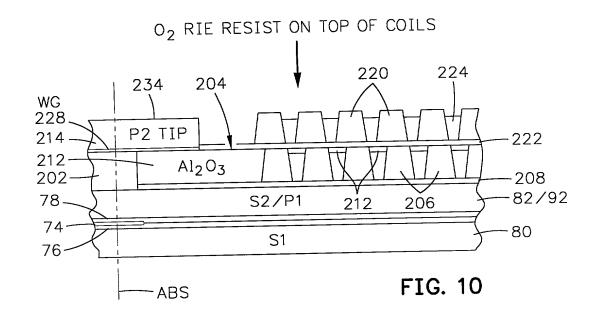
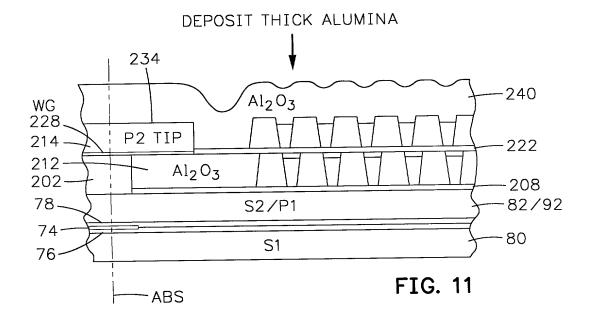


FIG. 5 (PRIOR ART)

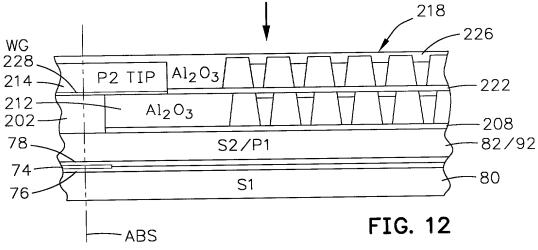




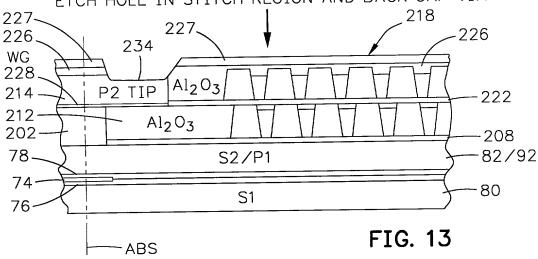


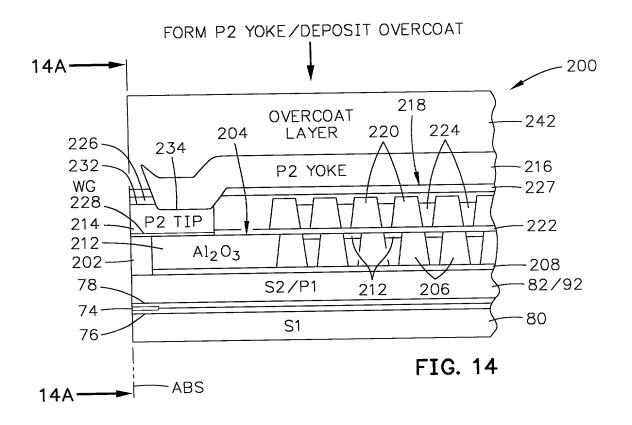






DEPOSIT COILS INSULATION (ALUMINA) AND ETCH HOLE IN STITCH REGION AND BACK GAP VIA





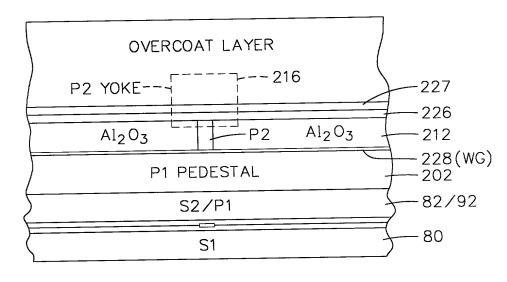
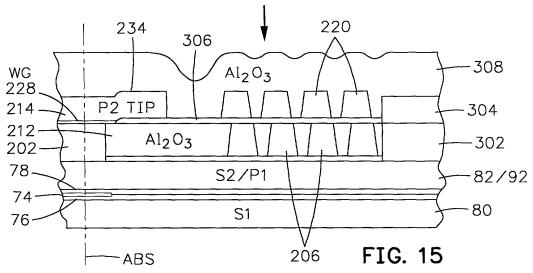
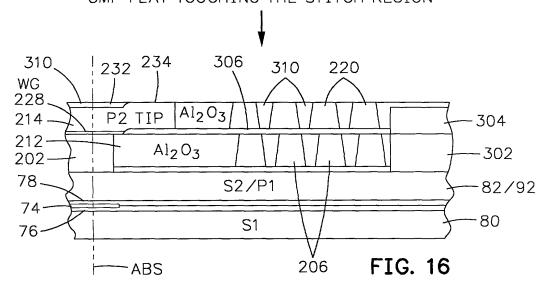


FIG. 14A

DEPOSIT THICK PLANARIZING ALUMINA



CMP FLAT TOUCHING THE STITCH REGION



O 0

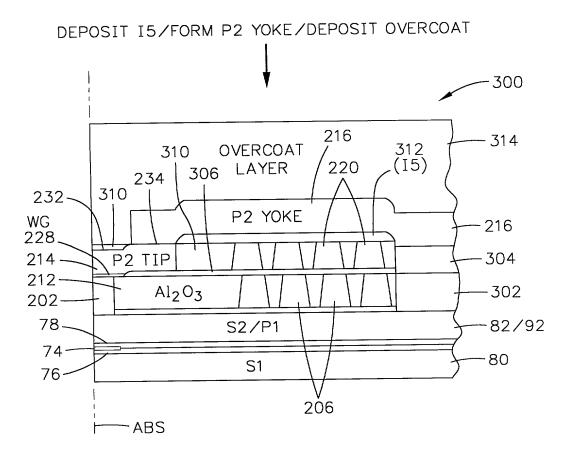


FIG. 17

